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4/4/02
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

KAZUYUKI KURODA ET AL. ✓

Application No.: 09/478,884 ✓

Filed: January 7, 2000 ✓

For: ✓ MESOSTRUCTURED MATERIALS,
SILICA MESOSTRUCTURED
MATERIALS, PREPARATION
METHODS THEREOF AND
CONTROL METHOD OF
MESOPORE ORIENTATION

)
:
Examiner: C. Simone ✓

)
:
Group Art Unit: 1772 ✓

)
:
March 20, 2002

Commissioner for Patents
Washington, D.C. 20231

AMENDMENT

RECEIVED
APR 03 2002
TC 1700

Sir:

In response to the Office Action dated December 20, 2001, please amend the above-captioned application as follows and consider the following remarks.

IN THE ABSTRACT:

Please replace the abstract with the following. A marked-up copy of the original text, showing the changes made thereto, is attached.

04/02/2002 NMOHAMH1 00000002 09478884

01 FC:103
02 FC:102

54.00 OP
84.00 OP

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231 on
March 20, 2002
(Date of Deposit)

Jason M. Okun
(Name of Attorney for Applicants)
Signature March 20, 2002
Date of Signature